Serial No: Docket No.: RD-28-444-2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: J.W. EBERHARD, ET AL

Serial No.:

Filed:

Group Art Unit:

For: RADIATION IMAGING SYSTEM AND METHOD OF COLLIMATION

INFORMATION DISCLOSURE STATEMENT CONTINUING APPLICATION

Honorable Assistant Commissioner of Patents Washington, DC 20231

SIR:

This Information Disclosure Statement is being filed under 37 C.F.R. §1.56 for a continuing application, which relies on the filing date of its parent application, such parent application being identified as:

U.S. Patent Application Serial No: 09/683,564 Examiner: A. HO

Filed: 1/18/02

Inventor(s): JEFFREY W. EBERHARD, ET AL

Title: RADIATION IMAGING SYSTEM AND METHOD OF COLLIMATION

Enclosed is a listing of all "prior art" cited and submitted in the parent application cited on PTO-1449 and Form PTO-892 listing "prior art" cited by the Examiner in the parent application. Pursuant to 37 C.F.R. §1.98(d), no actual copies of the documents listed are being furnished to the PTO with this Information Disclosure Statement.

Respectfully submitted,

ANN M. AGOSTI PATENT COUNSEL

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DATE: 10 Sept 03

| SUBSTITUTE FORM PTO-1449 US. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | | | | ATTY. DOCKET NO. RD-28,444-2 | | SERIAL NO. |
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| INFORMATION DISCLOSURE STATEMENT -CONTINUING APPLICATION LIST OF ITEMS CITED BY APPLICANT AND EXAMINER | | | | | Applicant | | |
| | | | | | JEFFREY W. EBERHARD, ET AL | | |
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| OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.) | | | | | | | |
| | CA | | | | | | |
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| EXAMINER | | | | | DATE CONSIDERED | | |
| EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant | | | | | | | |